

Notice of References Cited	Application/Control No. 10/595,191		Applicant(s)/Patent Under Reexamination NAKAMURA, TADASHI	
	Examiner NICHOLAS LEE		Art Unit 2627	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0114474	06-2004	Park et al.	369/030.05
*	B	US-2004/0223440	11-2004	Park, Yong Cheol	369/059.25
*	C	US-2004/0185216	09-2004	Hwang et al.	428/064.4
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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